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Dated: May 19, 2006

Signature:

(Andrew T. Zidel)

Docket No.: SCEI 3.0-200
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Keisuke Inoue

Application No.: 10/812,155

Group Art Unit: 2115

Filed: March 29, 2004

Examiner: T. C. Lee

For: METHODS AND APPARATUS FOR
ACHIEVING THERMAL MANAGEMENT
USING PROCESS OR MANIPULATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT AND
CERTIFICATION PURSUANT TO 37 C.F.R. § 1.97(E) (1)**

Dear Sir:

It is respectfully requested that the references listed on the enclosed form, which were cited on an International Search Report, be made of record and considered with respect to the above-referenced U.S. patent application. A copy of each non-US reference, and the search report, are enclosed. Submission of the present Information Disclosure Statement should not be taken as an admission that the cited references are legally available prior art or that the same are pertinent or material.

Pursuant to 37 C.F.R. § 1.97(e) (1), undersigned counsel hereby certifies that each item of information contained in the accompanying Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application to the above-referenced patent application not more than three months prior to the filing of said

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statement.

In the event that any fee is due in connection with the present Information Disclosure Statement, the Commissioner is hereby authorized to charge the same to our Deposit Account No. 12-1095.

Dated: May 19, 2006

Respectfully submitted,

By 

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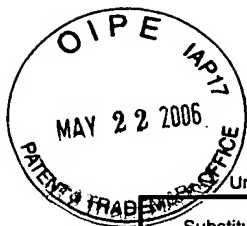
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PTO/SB/08a/b (07-05)

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number	10/812,155-Conf. #2941
Filing Date	March 29, 2004
First Named Inventor	Keisuke Inoue
Art Unit	2115
Examiner Name	T. C. Lee
Attorney Docket Number	SCEI 3.0-200

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	AA*	US-2003/0110012-A1	10-12-2004	Orenstien et al.	
	AB*	US-2003/0229662-A1	12-11-2003	Luick	
	AC*	US-2005/0278520-A1	12-15-2005	Hirai et al.	
	AD*	US-2004/0003309-A1	01-01-2004	Cai et al.	
	AE*	US-6,269,043-B1	07-31-2001	Batcher	
	AF*	US-6,192,479-B1	02-20-2001	Ko	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	BA	WO-03/083693-A	10-09-2003	FUJITSU LIMITED		**
	BB	JP-08-016531-A	01-19-1996	HITACHI LTD		**
	BC	JP-10-240704-A	09-11-1998	RICOH CO LTD		**

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. * CITE NO.: Those application(s) which are marked with an single asterisk (*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	SEONGMOO HEO et al, "Reducing Power Density Through Activity Migration", Proceedings of the 2003 International Symposium on Low Power Electronics and Design, Seoul, Korea, Aug. 25-27, 2003.	**

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** - English abstract attached.

Examiner Signature		Date Considered	
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